



**ELECTRONIC COPY**

LG786665168  
Report verification at igi.org



March 31, 2026  
IGI Report Number **LG786665168**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **11.34 X 8.00 X 5.54 MM**  
**GRADING RESULTS**  
Carat Weight **4.54 CARATS**  
Color Grade **F**  
Clarity Grade **VS 1**

March 31, 2026  
IGI Report Number **LG786665168**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED RECTANGULAR  
MODIFIED BRILLIANT**  
Measurements **11.34 X 8.00 X 5.54 MM**

**GRADING RESULTS**

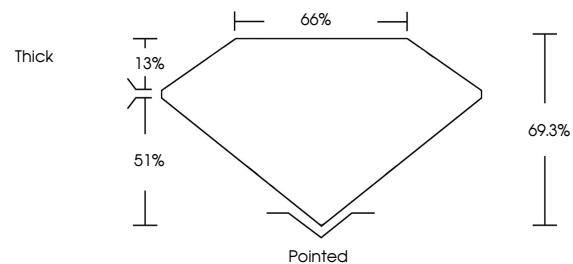
Carat Weight **4.54 CARATS**  
Color Grade **F**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

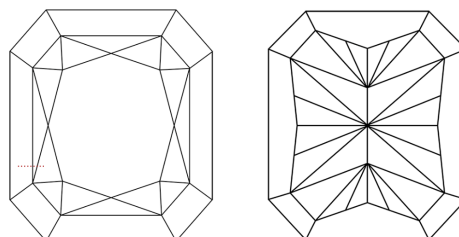
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG786665168**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

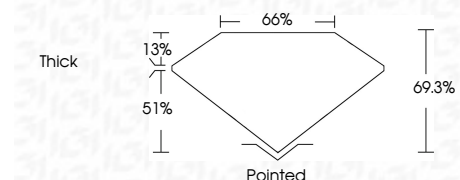
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG786665168**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



March 31, 2026  
IGI Report No LG786665168  
CUT CORNERED RECT. MODIFIED BRILLIANT  
11.34 X 8.00 X 5.54 MM  
Carat Weight 4.54 CARATS  
Color Grade F  
Clarity Grade VS 1  
Depth 69.3%  
Table 65%  
Girdle Thick  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG786665168  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa